Docket No.: KUD-008

## AP20 Rec'd PCT/PTO 0 4 AUGT 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Confirmation No.

Kenji FUJIWARA et al

U.S. Patent Application No.: -----

Group Art Unit: -----

Filed: August 4, 2006

For: IPM ELECTRIC ROTATING MACHINE

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

Respectfully submitted,

KANESAKA BERNER & PARTNERS

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## AP20 Rec'd PCT/PTO 04 AUG 2005 heet 1 of 1

INF	ORMATION :	ATTY. DOCKET NO. KUD-008		U.S. APPLICATION NO. Not yet assigned				
CITATION IN AN APPLICATION (PTO-1449)				APPLICANT 40/588516 Kenji FUJIWARA et al 0./588516				
				FILING DATE August 4, 2006		GROUP		
	(110-1		TENT DO	CUMENTS				
EXAMINER'S INITIALS	PATENT NO.	DATE		NAME		SUBCLASS	FILING DATE	
		FOREIGN	PATENT	DOCUMENTS				
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS	Transla Yes	No No
	JP2002-153033 A	05/24/2002	Japan				Abstract	
	JP2003-199273 A	07/11/2003	Japan				Abstract	
	JP2000-228890 A	08/15/2000	Japan				Abstract	
	JP 2003-284274A	10/03/2003	Japan				Abstract	
Section Section 19: 10: 10: 10: 10: 10: 10: 10: 10: 10: 10								
	OTHER	ART (Including A	uthor, 11t	le, Date, Pertinent	rages, Et	c.)		
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EXAMINER		DA	OATE CONSIDERED					

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.